

**Notice of References Cited**

Application/Control No.

09/810,333

Applicant(s)/Patent Under  
Reexamination  
BEHIN ET AL.

Examiner

Tamai IE Karl

Art Unit

2834

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*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
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	B	US-6000280	12-1999	Miller et al.	73/105
	C	US-6253612 ✓	07-2001	Lemkin et al.	73/504.02
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	O	0715981 ✓	07-1995	Japan	Nakagawa et al.	H02N001/00
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**NON-PATENT DOCUMENTS**

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)				
	U	Xie et al., "A CMOS Z-Axis Capacitive Accelerometer with Comb Finger Sensing", The 13th Annual International Micro Electro Mechanical Systems Conference (Miyazaki, Japan), Jan 23-27, 2000, pp. 496-501. ✓				
	V	Translation of JP 4-343318, 11/1992 ✓				
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\*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)

Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.